

0977260.020501

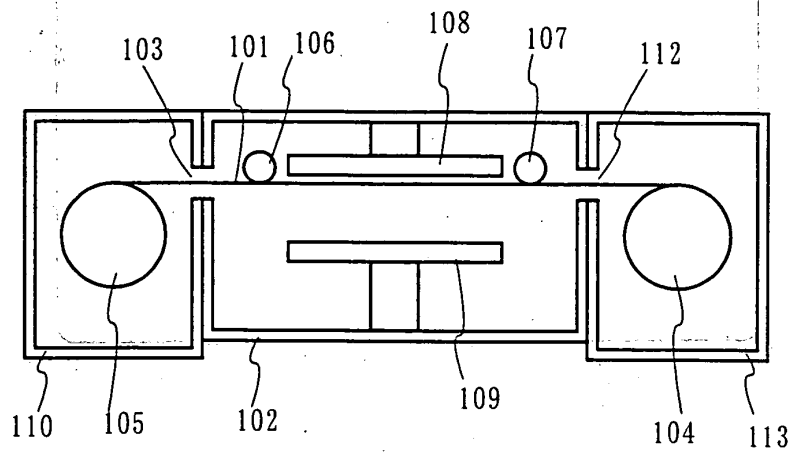


FIG. 1A

PRIOR ART

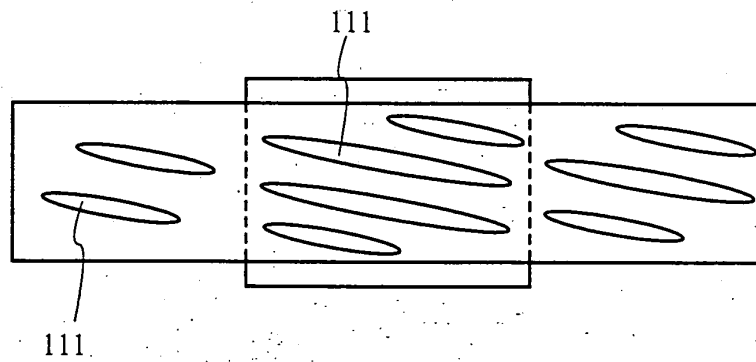
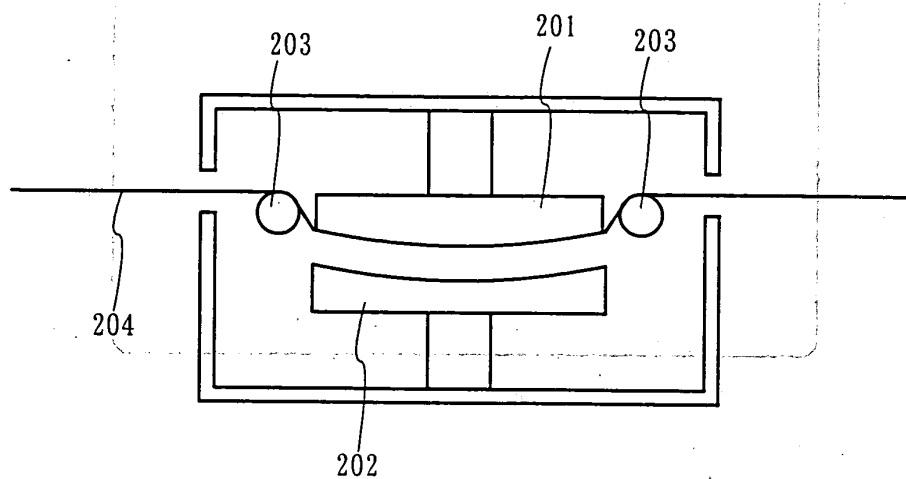


FIG. 1B

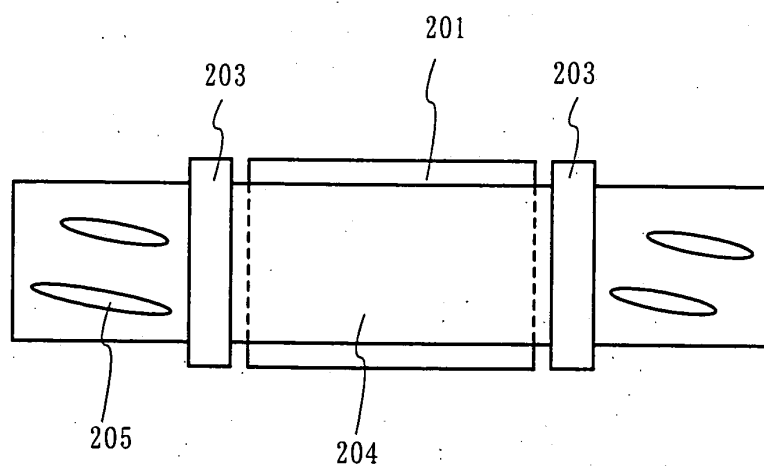
PRIOR ART

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PRIOR ART

FIG. 2A



PRIOR ART

FIG. 2B

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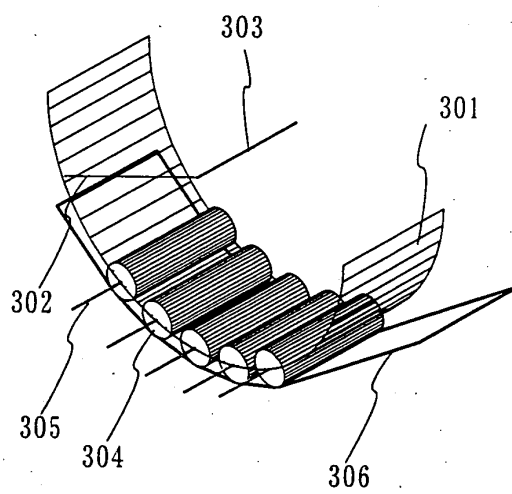
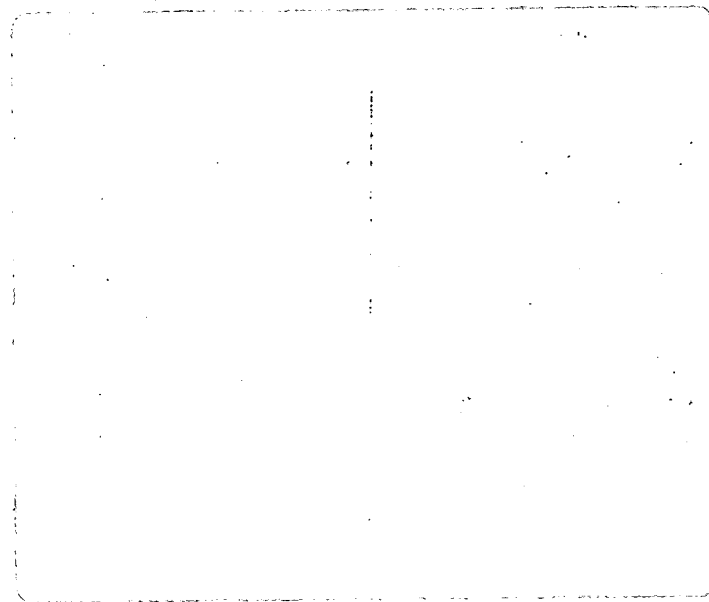


FIG. 3

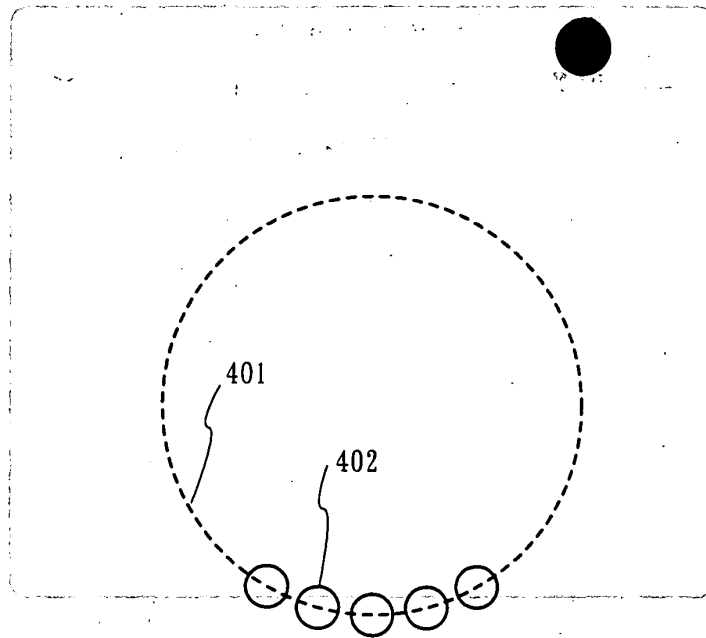


FIG. 4A

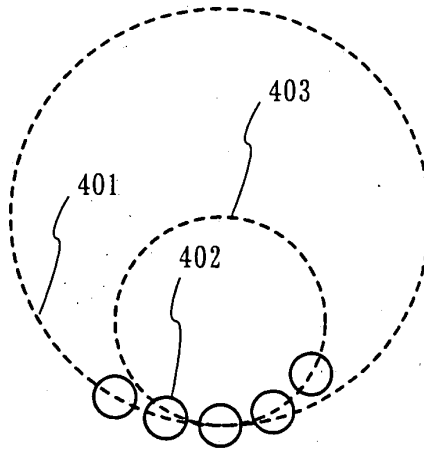


FIG. 4B

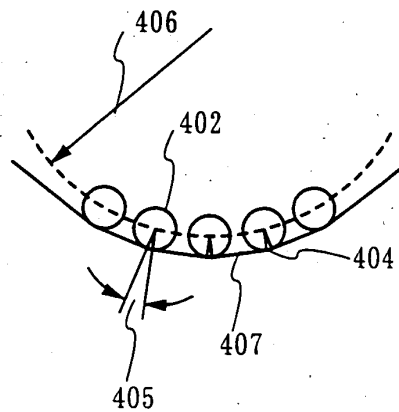
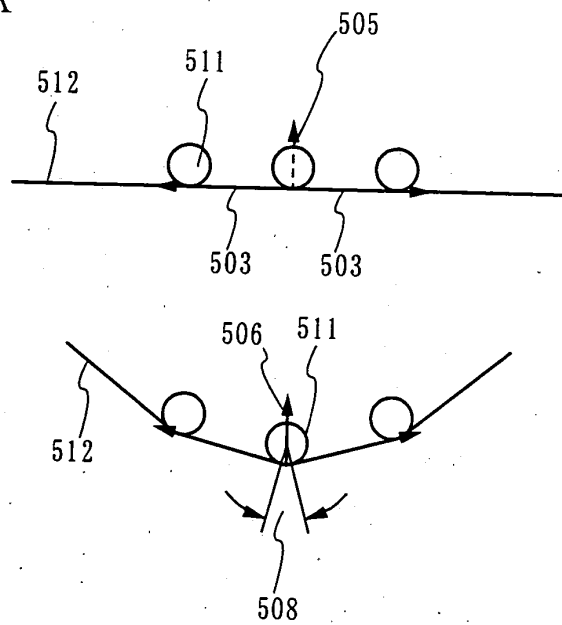
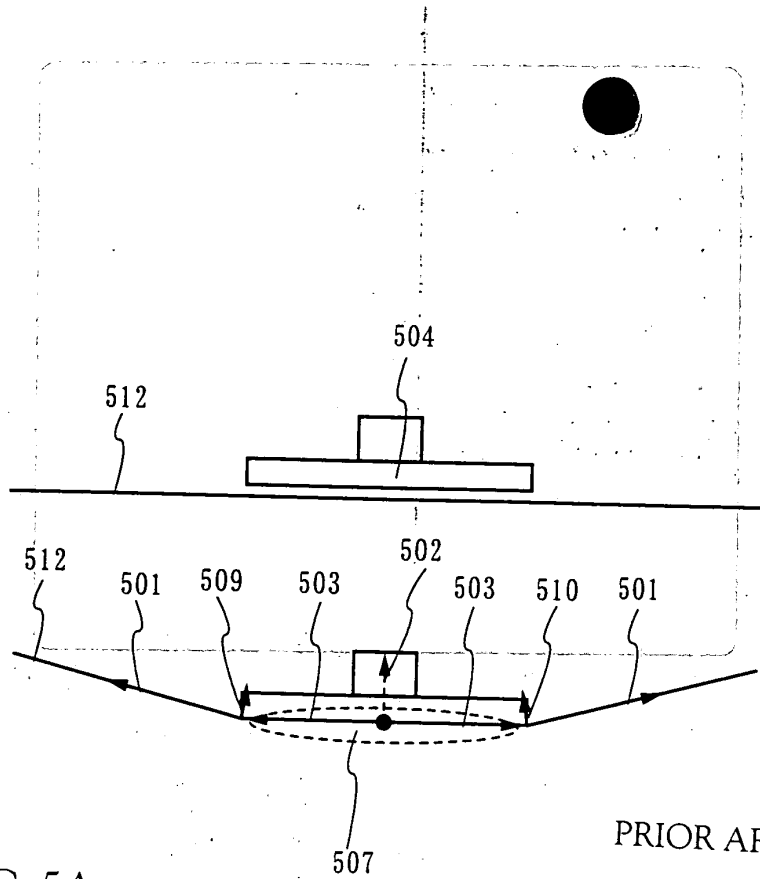


FIG. 4C

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This diagram shows a cross-sectional view of a device. It features a central assembly (601, 602, 603, 604, 605, 606, 607, 608, 609) and two side chambers (603, 605). The central assembly includes a central core (601) with a series of vertical segments (602, 603, 604, 605, 606, 607, 608, 609). The side chambers (603, 605) contain circular components (603, 605). The entire device is enclosed in a housing (601, 602, 603, 604, 605, 606, 607, 608, 609).

A cross-sectional view of a device. It features a central rectangular cavity (601) bounded by a top wall (602) and a bottom wall. The cavity is flanked by two vertical side walls (606). The left side wall is part of a larger structure containing two elongated oval shapes. The right side wall is also part of a larger structure containing two elongated oval shapes. Dashed lines indicate the boundaries of the central cavity.

FIG. 6B

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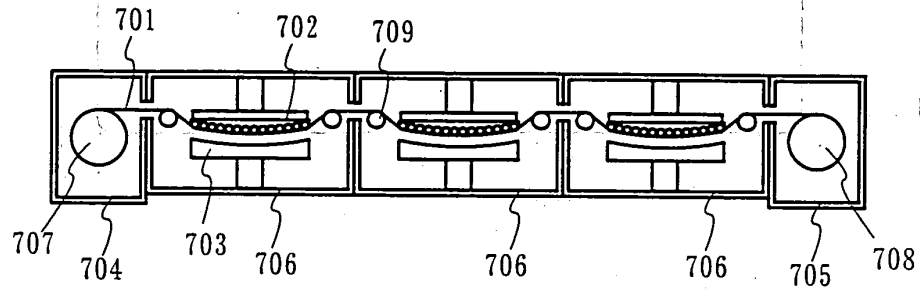


FIG. 7A

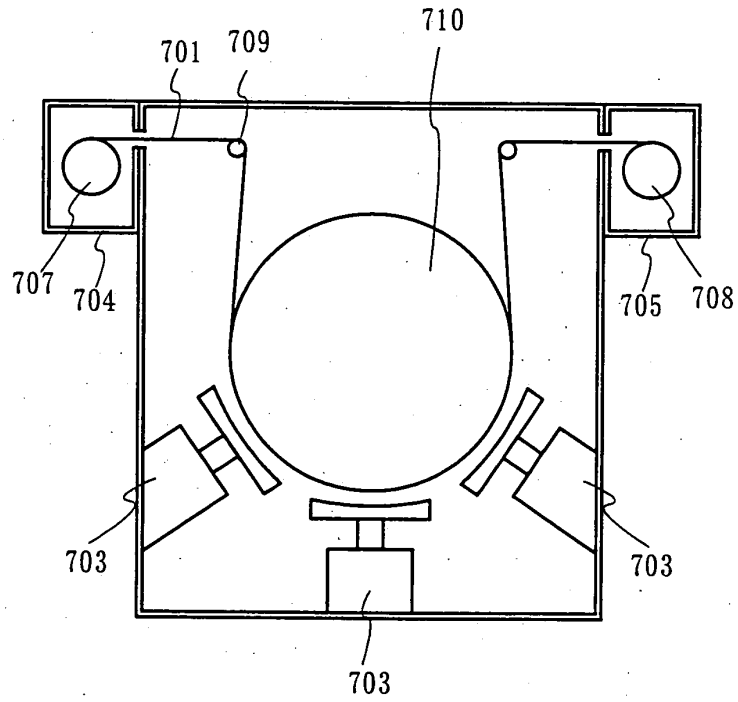


FIG. 7B

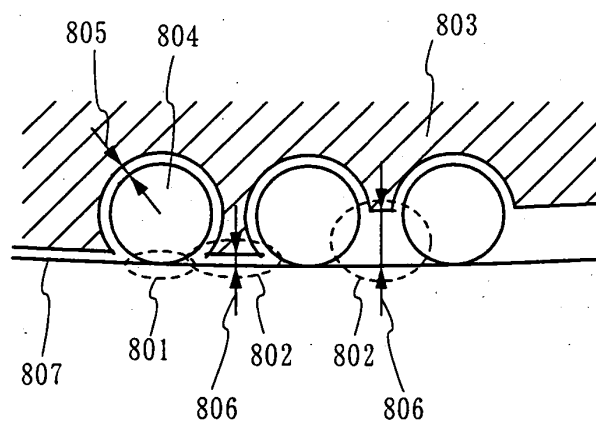
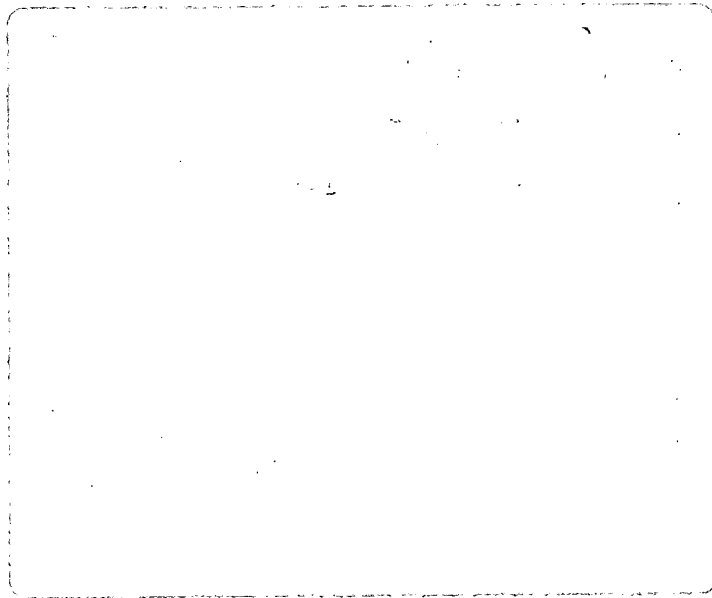


FIG. 8

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T05020 0827250

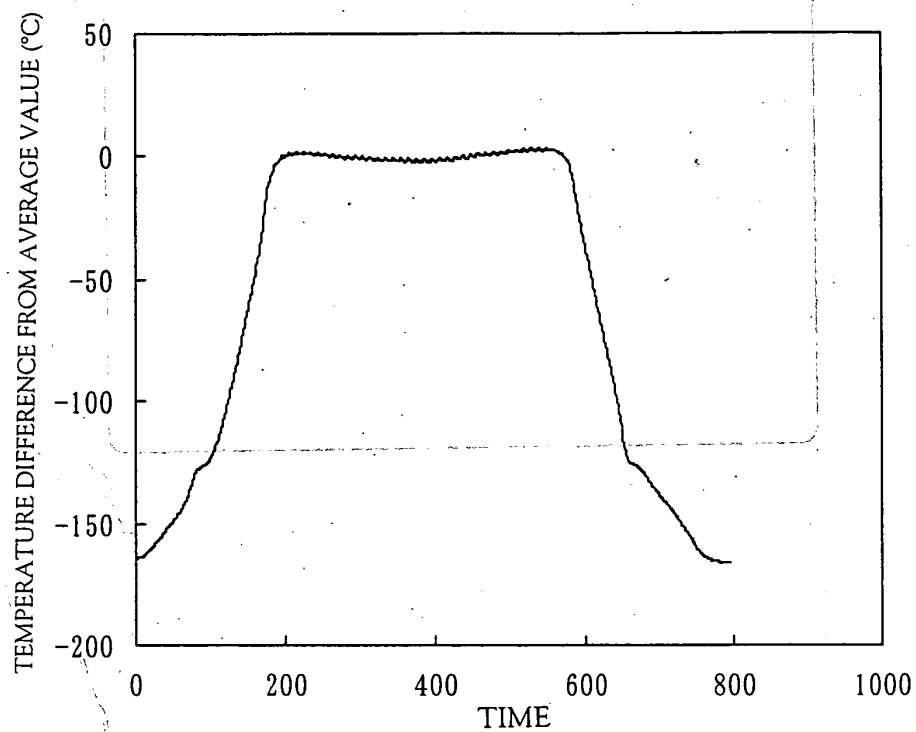


FIG. 9A

MEASUREMENT OF TEMPERATURE OF
CURVED SURFACE ROLLER METHOD ELECTRODE

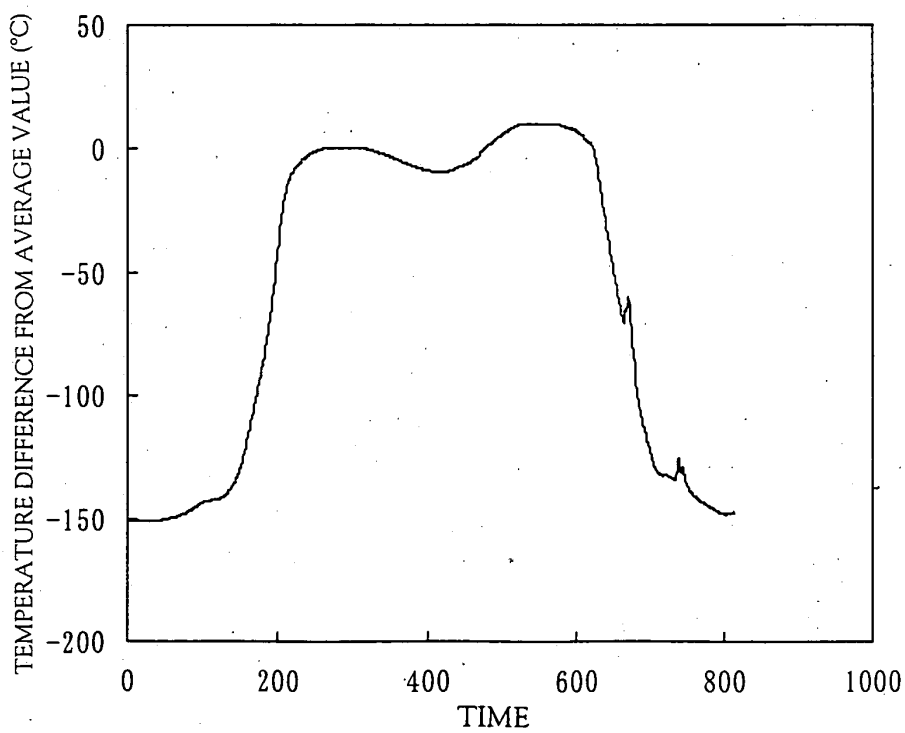


FIG. 9B

MEASUREMENT OF TEMPERATURE OF
PARALLEL PLATE METHOD ELECTRODE

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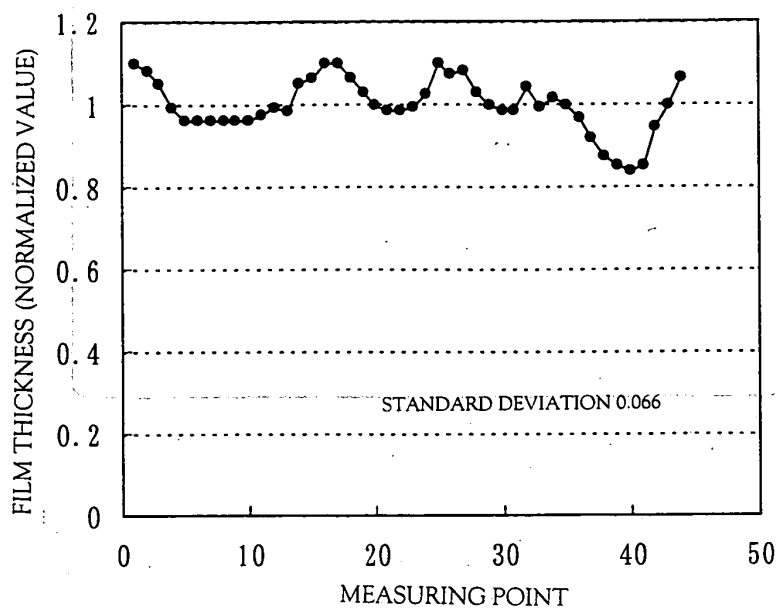


FIG. 10A

FILM FORMATION WITH PARALLEL PLATE METHOD ELECTRODE AND MEASUREMENT OF FILM THICKNESS IN SUBSTRATE WIDTH DIRECTION

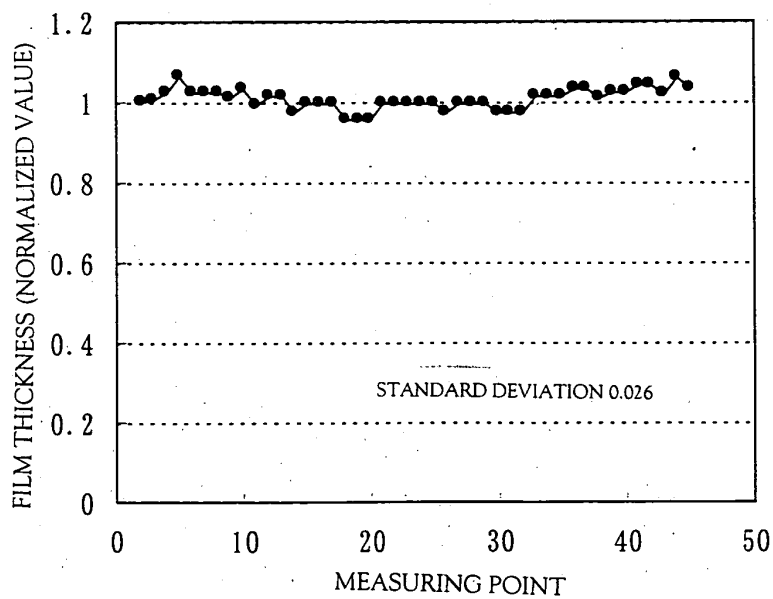


FIG. 10B

FILM FORMATION WITH CURVED SURFACE ROLLER METHOD ELECTRODE AND MEASUREMENT OF FILM THICKNESS IN SUBSTRATE WIDTH DIRECTION